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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

MICHIO SATO, ET AL. :

SERIAL NO: 09/926,041 :

FILED: AUGUST 20, 2001 :

FOR: COMPONENTS FOR VACUUM
DEPOSITION APPARATUS AND
VACUUM DEPOSITION
APPARATUS THEREWITH, AND
TARGET APPARATUS

EXAMINER: MCDONALD, R. G.

GROUP ART UNIT: 1753

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W.M.
2/4/03

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AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

In response to the Office Action dated October 29, 2002, please amend the above-identified application as follows:

IN THE CLAIMS

Please amend claims 1, 4, 5, 9, 11, 12, 16, 24, and 25 as shown in the attached marked-up claims to read as follows:

1. (Amended) A component of a vacuum deposition apparatus, comprising:
- a component body; and
 - a spray deposit coated on a surface of the component body and having surface roughness in which a mean spacing S of tops of local peak of profile is in a range from 50 to 150 μm , a distance from a mean line to a bottom of profile valley line Rv is in a range from 20 to 70 μm , and a distance from a mean line to a top of profile peak line Rp is in a range from 20 to 70 μm .

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